

LHC Injectors Upgrade





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New ion injection system in the SPS T.Kramer B.Balhan, J.Borburgh, L.Ducimetière, B.Goddard, W.Höfle, M.Hourican, L.Jensen, G.Kotzian, K.Li, F.L.Maciariello D.Manglunki, A.Mereghetti, B. Salvant, L.Sermeus, J.Uythoven, F.M.Velotti, C.Zannini

LIU-day 2014, April 11th



Motivation: Higher \mathcal{L} for ions after LS2 by increasing the total bunch number

□ WHY?

- The average bunch brightness is already high (twice nominal).
- Increasing it (if possible) leads to more IBS in SPS and LHC, and also increases \pounds burnoff.

□ HOW?

- Reducing average bunch spacing in the LHC.
- Reducing bunch spacing by batch compression in the PS.
- Decreasing batch spacing in SPS by a shorter injection kicker rise time to get batches closer.
- Implies a new SPS injection system for ions.



Review of early developments

In October 2013 a review took place to condense the various versions studied in the field of:

- Injection concept/beam optics
- Fast pulsed magnet systems
- Septum System
- Dump Block feasibility
- Beam Instrumentation
- Transverse Damper
- Failure scenarios
- Impedance considerations

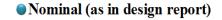
https://indico.cern.ch/event/263338/overview

A clear recommendation was made: "to follow the conservative 100ns approach rather than try to overcome all technical challenges for a faster 50 or 75ns solution."

https://edms.cern.ch/document/1331860/1.0



Estimated Peak Luminosity (w.r.t. nominal)

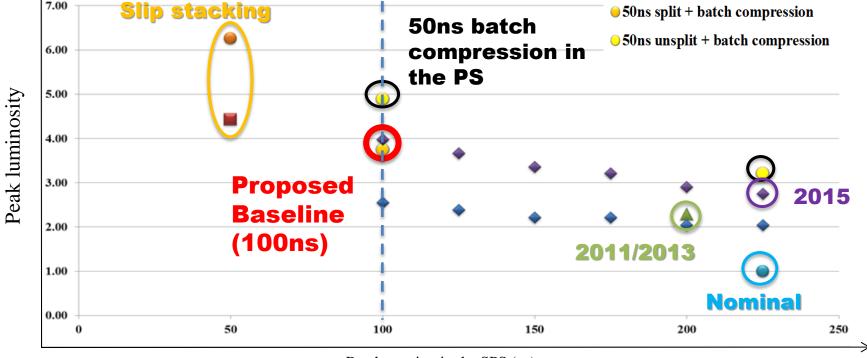


- ▲ 200ns Intermediate beam (performance of 2011)
- ◆100 ns beam unsplit (performance of 2013)
- ◆100ns beam split (140% performance of 2013)

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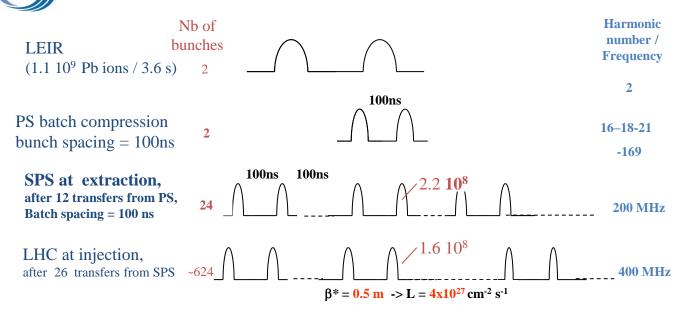
- 100 ns beam split w slip stacking
- 100 ns beam unsplit w slip stacking



Batch spacing in the SPS (ns)

Λ

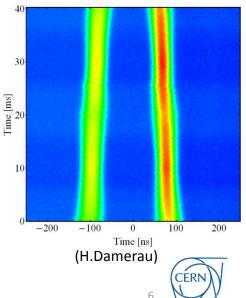
100ns Baseline scheme and parameters



Modified RF gymnastics in PS (demonstrated end 2012)

- Batch compression $(h = 16 18 21) \rightarrow 2$ bunches spaced by 100 ns
- □ 12 (t.b.c./optimized) injections into SPS spaced by 100 ns
 - 2.3 µs trains of 24 bunches spaced by 100 ns
- 26 injections/ring into LHC
 - 624 bunches/ring (factor ~1.74)
 - >25' filling time per ring on paper

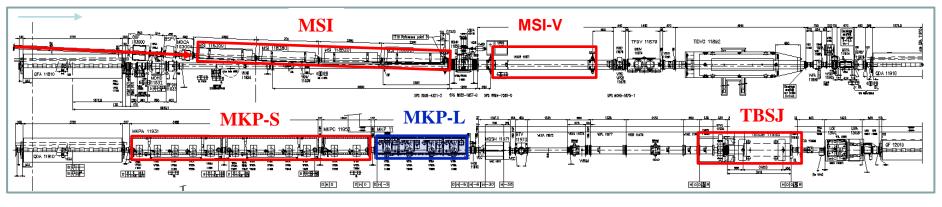
 $\Box Expected Pb-Pb \pounds_{peak} = 4.0x10^{27} \text{ cm}^{-2} \text{s}^{-1} \ (\beta^* = 0.5 \text{ m})$



Courtesy D. Manglunki

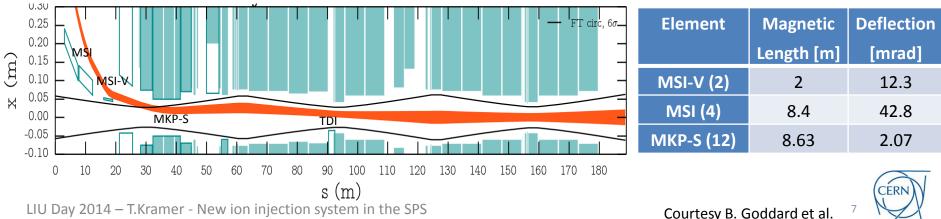
New SPS Injection Layout for Ions (100ns)

SPS LSS1



- Use existing (fast) MKP-S kicker with additional PFL.
- Additional septa (MSI-V) needed.
- Requires ion injection dump upstream QD12110.

- 17 GeV/c/u PB⁸²⁺
- 100 ns rise time
- Q20 compatible
- Low impedance impact

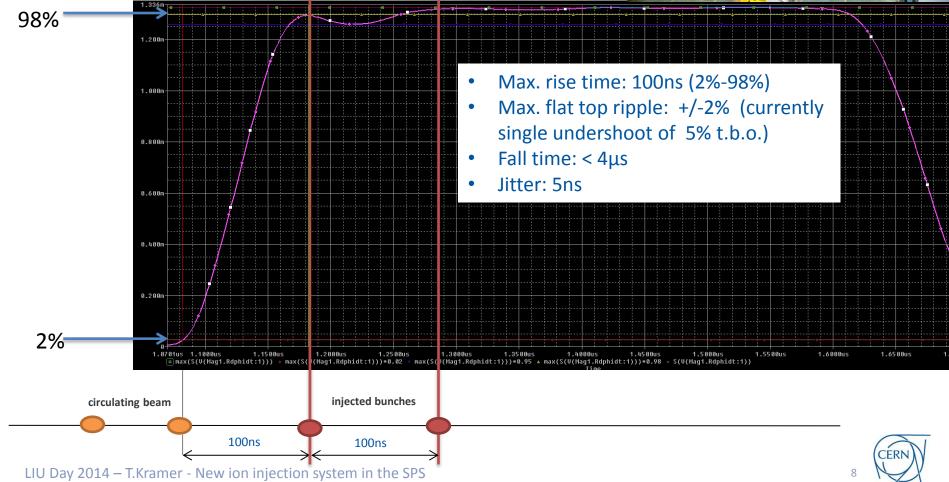


Fast injection kicker system

Use MKP-S magnets with new PFL (MKP-L too slow).

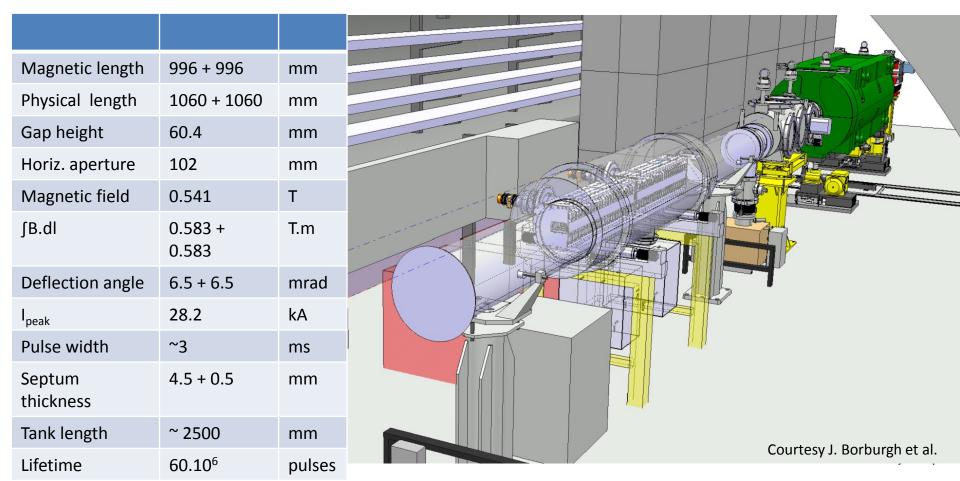
- No layout or equipment change in the tunnel!
- No change to p⁺ inj. System (except switch).
- Needs transverse damper to limit blow up.

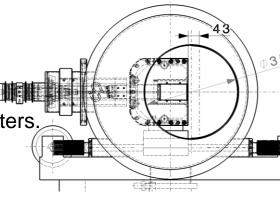




Ion injection septum (MSI-V)

- Under vacuum pulsed magnet, powered by 2 MegaDiscap converters,
- Newly to build vacuum vessel.
- 2 magnets re-used from PSB to PS TL.
- Outstanding challenges: radiation hardness, reliability and integration in the existing (crowded) area.





Possible Impact On/From the SPS Transverse Damper

 \Box Large kick angle of injection kicker: 2.07mrad @ avg. β =45.4m

for given specs (100ns, 2%-98%, 5ns jitter, steering error 0.5mm) worst case: 6.6mm @ β_{ref} =100m

Estimation of emittance blow-up

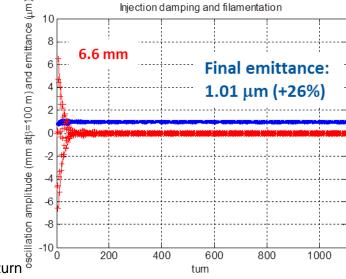
- based on numerical simulations (MATLAB)
- assuming amplitude detuning of 5e-5 m⁻²
- Damper gain 0.1 or damping time 20 turns
- Expected final emittance: 1.01 µm (26 % blow-up)
- Damper kick strength for ions (horizontal plane)

$$\delta_{\rm ions} = \delta_{\rm protons} \frac{\beta \gamma_{\rm protons}}{\beta \gamma_{\rm ions}} \frac{82}{208} = 1.5 \ \delta_{\rm protons}$$

- for damping time 20 turns gain of 0.1 needed, requires at max. 10% reduction/turn 0.49 mm/turn is sufficient to damp 4.9 mm with 20 turns \rightarrow
- \rightarrow

Transverse damper vital to limit emittance blow up. (Estimated 200% emittance blow up without damper!)

Ion specific Low-Level needed due to the frequency modulation of the RF: 4 different clocks from RF (BA3) to damper (BA2) with frequency modulation shifted to correct azimuthal position for pick-ups and kickers.





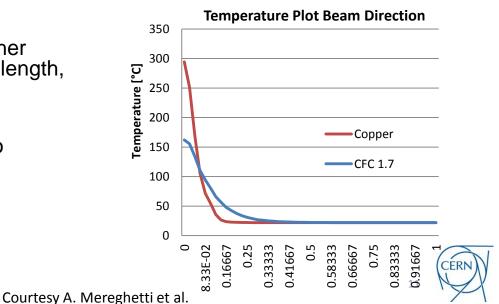


FLUKA simulations were run to estimate levels of energy deposition and escaping neutrons for a 1m-long absorber protecting QD.12110;

□ Full impact case of the SPS ²⁰⁸Pb⁸²⁺ ion beam (50ns, 4 bunches) at inj. energy was studied;

Two materials considered: Cu and CfC:

- Energy deposition: CfC is generally featured by values lower than those of Cu;
- Cu absorbs more beam energy (60% vs 20%) and generates more populated but softer spectra of escaping neutrons;
- With respect to CfC, Cu generates more populated but softer neutron spectra; with CfC, a more intense high energy neutron component can start particle showers in the downstream device(s);
- for both material, activation of the surroundings is expected (actual estimation only possible at a more advanced stage of design);
- The dump block is feasible, however further optimisations must be done in terms of length, activation, escaping neutrons etc...
- Material characteristics to be adjusted to match the requirements.





- Existing beam instrumentation (TT10 and RING) can be used.
- Additional BTV to be integrated on new dump. (radiation-hard "Vidicon"camera)
- BLMs to be specified and placed for new injection septum and dump
- New BPM electronics expected to bring new functionalities for injection oscillation and covering long cycles
- □ Fast kicker synchronization to be done as for protons (BCT)

Next steps:

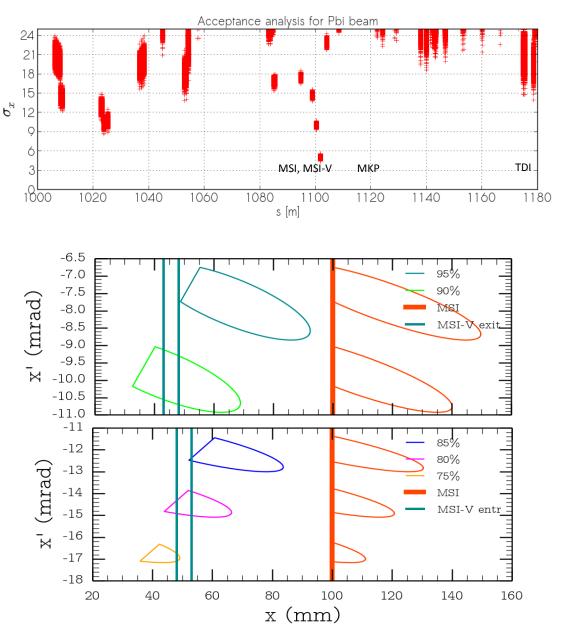
- Choice of screen materials to be reviewed
- Review of BTV tank impedance







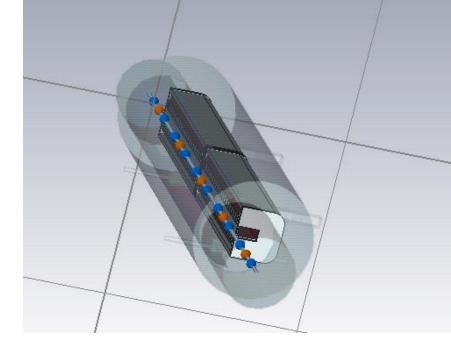
- Failure cases considered:
 - Injection kicker, MKP, not firing;
 - Main magnet failures in the transfer line PS to SPS;
 - MSI-V failures;
 - Proton injection septum, MSI, failures.
- Ion operation with 2 bunches not critical
- Proton operation needs MSI current to be monitored and interlocked to protect MSI-V.

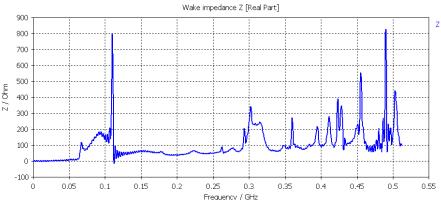






- Studies for the impedance impact of a dedicated 50 ns ion kicker have been made and yield a significant contribution to long. and transv. impedance.
- Significant reason for the review committee recommendation (100ns upgrade) was to not add additional impedance for kicker systems.
- Preliminary studies for MSI-V done. Further optimization envisaged.
- Check for BTV and dump to be done.









Various designs have been elaborated in 2013.

Review concluded on a clear **recommendation** for a **100ns upgrade**.

Feasible and cost effective solution:

- New PFL system on MKP-S allows to not change the kicker infrastructure in the tunnel. No dose taken by FPS-personal (next to TIDVG). Further development ongoing.
- No new ion kicker magnets thus no additional impedance for kickers added.
- Additional MSI-V Septa will make use of recovered PSB2PS septa magnets. Impedance to be checked.
- Most existing beam instrumentation can be used.
- Transvers damper vital to keep emittance blow up small.
- New ion dump feasible. Requirements to be defined-> Further detailed studies needed.
- SPS amplitude detuning needs to be evaluated.
- Emittance blow up budget for ion injection activities needs to be defined.



- 2013 Review of variants – Decision for 100ns upgrade.
- 2014 Specifications, start of technical design.
- 2015-2017Prototypes, production.
- 2018-2019 (LS2) Installation.





LHC Injectors Upgrade

THANK YOU FOR YOUR ATTENTION!

